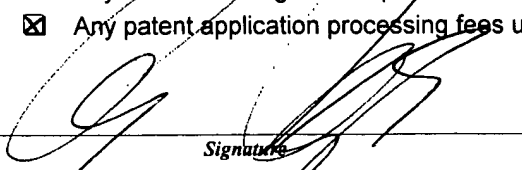
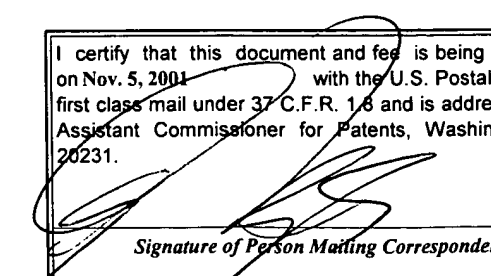


AMENDMENT TRANSMITTAL LETTER (Large Entity)			Docket No. NPO0005		
Applicant(s): Keiji Ishibashi					
Serial No. 009/633,002	Filing Date August 4, 2000	Examiner W. Markham	Group Art Unit 1762		
Invention: PHOTOCOPY ELEMENT CVD APPARATUS AND A METHOD FOR REMOVING A DEPOSITED FILM					
TO THE ASSISTANT COMMISSIONER FOR PATENTS:					
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	6 -	20 =	0 x	\$18.00	\$0.00
INDEP. CLAIMS	1 -	3 =	0 x	\$84.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00
<input checked="" type="checkbox"/> No additional fee is required for amendment. <input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of _____ A duplicate copy of this sheet is enclosed. <input type="checkbox"/> A check in the amount of _____ to cover the filing fee is enclosed. <input checked="" type="checkbox"/> The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. _____ A duplicate copy of this sheet is enclosed. <input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16. <input checked="" type="checkbox"/> Any patent application processing fees under 37 CFR 1.17.					
 Signature			Dated: November 5, 2001		
Anthony Niewyk, Registration No. 24,871 Baker & Daniels 111 E. Wayne Street, Suite 800 Fort Wayne, IN 46802 Telephone: 219-424-8000 Facsimile: 219-460-1700					
<div style="border: 1px solid black; padding: 5px; display: inline-block;"> RECEIVED FEB 11 2002 TC 1700 </div>					
<div style="border: 1px solid black; padding: 5px; display: inline-block; width: 300px;"> I certify that this document and fee is being deposited on Nov. 5, 2001 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.6 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.  Signature of Person Mailing Correspondence Anthony Niewyk, Registration No. 24,871 Typed or Printed Name of Person Mailing Correspondence </div>					
cc:					



PATENT
NPO0005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of) Customer No. 00832
Keiji Ishibashi)
Serial No. 09/633,002) Group: 1762
Filed: August 4, 2000)
Title: A HOT ELEMENT CVD APPARATUS) Examiner: W. Markham
AND A METHOD FOR REMOVING)
A DEPOSITED FILM)

#7/B
Healy
2/12/02

AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Responsive to the Office Action dated July 5, 2001, which had a period for response which expired on October 5, 2001, which period has been extended by the enclosed Petition For Extension Of Time to expire on November 5, 2001, Applicant hereby submits the following response:

IN THE CLAIMS:

Cancel claims 17-20.

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REMARKS

Claims 11-16 are at issue. Claims 17-20 have been canceled as drawn to a non-elected invention. No claims have been allowed.

Applicant reserves the right to file a divisional patent application on canceled claims 17-20.

Claims 11, 12, 15, and 16 have been rejected under 35 U.S.C. 103(a) as unpatentable over Matsuyama in view of Niino et al.

Matsuyama teaches a CVD method comprising feeding a filament of platinum, tungsten, or the like, supplying a material gas to a chamber, contacting the material gas with the heated filament to cause decomposition and/or activation of the material gas by the filament, and forming a deposition film on a substrate. Matsuyama does not teach a method